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PATENT

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APR 12 2002

John T. Pienkos, Reg. No. 42,997

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Richard D. Harris  
Application No.: 09/843,545  
Filed: April 26, 2001  
For: METHOD FOR FABRICATING AN ISOLATED  
MICROELECTROMECHANICAL SYSTEM  
(MEMS) DEVICE USING AN INTERNAL VOID  
Group Art Unit: 2812  
Examiner: --  
Atty. Docket No.: 110003.97460

INFORMATION DISCLOSURE STATEMENT  
UNDER 37 C.F.R. §§1.97 AND 1.98

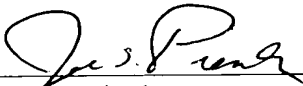
Commissioner for Patents  
Washington, D.C. 20231

Sir:

This paper is being presented for filing in the above case pursuant to Rules 97 and 98 of the Rules of Practice. A Form PTO-1449 "Information Disclosure Statement by Applicant" is attached which lists a reference cited and a copy of the reference is enclosed.

No additional fees for filing this paper are believed to be due. However, the Commissioner is hereby authorized to charge any additional fees due or to credit any overpayment to deposit account no. 17-0055.

Respectfully submitted,

  
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